## Notice of References Cited Application/Control No. | Applicant(s)/Patent Under Reexamination LIU ET AL. | Examiner | Art Unit | Eric B. Chen | 1765 | Page 1 of 1

## U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	U	Wolf et al., Silicon Processing for the VLSI Era, 1986, Lattice Press, Vol. 1, p. 184.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.